

Search Notes

Application/Control No.

10/670,425

Examiner

Dennis L. Vautrot

Applicant(s)/Patent under
Reexamination

LIU ET AL.

Art Unit

2167

SEARCHED

Class	Subclass	Date	Examiner
707	104.10	10/25/2006	DV
707	10	10/25/2006	DV

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
707	104	10/25/2006	DV
707	10	10/25/2006	DV

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Updated EAST search	10/26/2006	DV
ACM Portal	10/25/2006	DV
IEEE Expolore	10/25/2006	DV
Google	10/25/2006	DV
INSPEC	10/25/2006	DV
consult with and case reviewed by Kuen S. Lu, Patent Examiner, Art Unit 2167	10/25/2006	DV
consult with Luke Wassum for search help, Primary Examiner Art Unit 2167	10/25/2006	DV
consult with and case reviewed by John Cottingham, SPE Art Unit 2167	10/30/2006	DV